



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Patent Application )  
)  
TOMOO KOSUGI ET AL )  
)  
Serial No. 09/823,744 )  
)  
Filed: March 31, 2001 )  
)  
For: DESORPTION PROCESSING FOR )  
FLAT PANEL DISPLAY )

Group Art: 2833

Examiner: Edwin A. Leon

#4/A  
11-9-02  
RECEIVED  
DEC - 2 2002  
TECHNOLOGY CENTER 2300

RESPONSE

Commissioner for Patents  
Washington, D.C. 20231

Sir:

This is in full and timely response to the Office Action mailed August 28, 2002. Please amend the above-identified application as follows.

IN THE SPECIFICATION:

Please amend the specification as shown below in clean form. The marked-up version of the specification is appended hereto.

Please replace the paragraph beginning on page 2, line 13, with the following new paragraph:

AI  
Electron emissions in FEDs require a low internal pressure and that they be contaminant-free to avoid serious problems, such as pressure degradation, emission current degradation, and/or plasma generation or ionization which can lead to non-uniform brightness of the display, decrease display efficiency, and/or shortening of the working life of the display.